

<b>Notice of References Cited</b>	Application/Control No. 10/723,216	Applicant(s)/Patent Under Reexamination TAKOSHIMA ET AL.	
	Examiner Livius R. Cazan	Art Unit 3729	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,759,261	07-2004	Shimokohbe et al.	438/48
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	N	WO 9744676 A1 ✓	11-1997	World Intellect	KHANDROS et al.	
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	P					
	Q					
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**NON-PATENT DOCUMENTS**

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	U	Hata et al., "Fabrication of Thin Film Metallic Glass and its Application to Microactuator", October 1999, Conference on Device and Process Technologies for MEMS and Microelectronics, SPIE Vol. 3892, pp. 97-108 ✓
	V	Hata et al, "Fabrication of Micro Structures using Thin Film Metallic Glass", 2000, Journal of the Japan Society of Precision Engineering, Vol. 66, No. 1, pp. 96-101 ✓
	W	Jeong et al., "Microforming of Three-Dimensional Microstructures From Thin-Film Metallic Glass", IEEE, Journal of Microelectromechanical Systems, Vol. 12, No. 1, February 2003 ✓
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.